

## Patent Assignment Abstract of Title

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**Inventors:** Mikio Sanada, Sadayuki Sugama, Hiroki Hayashi

Method of reforming element surface, element with reformed surface, method of

**Title:** manufacturing element with reformed surface, surface treatment liquid for forming reformed surface, and method of manufacturing surface treatment liquid

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**Assignors:** SANADA, MIKIO

**Exec Dt:** 12/26/2000

SUGAMA, SADAYUKI

**Exec Dt:** 12/26/2000

HAYASHI, HIROKI

**Exec Dt:** 12/25/2000

**Assignee:** CANON KABUSHIKI KAISHA

30-2, SHIMOMARUKO 3-CHOME, OHTA-KU  
TOKYO, JAPAN

**Correspondent:** FITZPATRICK, CELLA, HARPER & SCINTO

PETER SAXON

30 ROCKEFELLER PLAZA

NEW YORK, NY 10112-3801

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